Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	191133	(Si or silicon) near substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/05 15:07
L2	162	nucleation with (polycrystal$4 near (nitride near semiconductor) or AlN or (aluminum near nitride))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/05 15:10
L3	1544	buffer same superlattice$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/05 15:11
L4	4	l1 and l2 and l3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/05 15:11